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Combined XRD and EXAFS study of Cr-AI-N gradient samples

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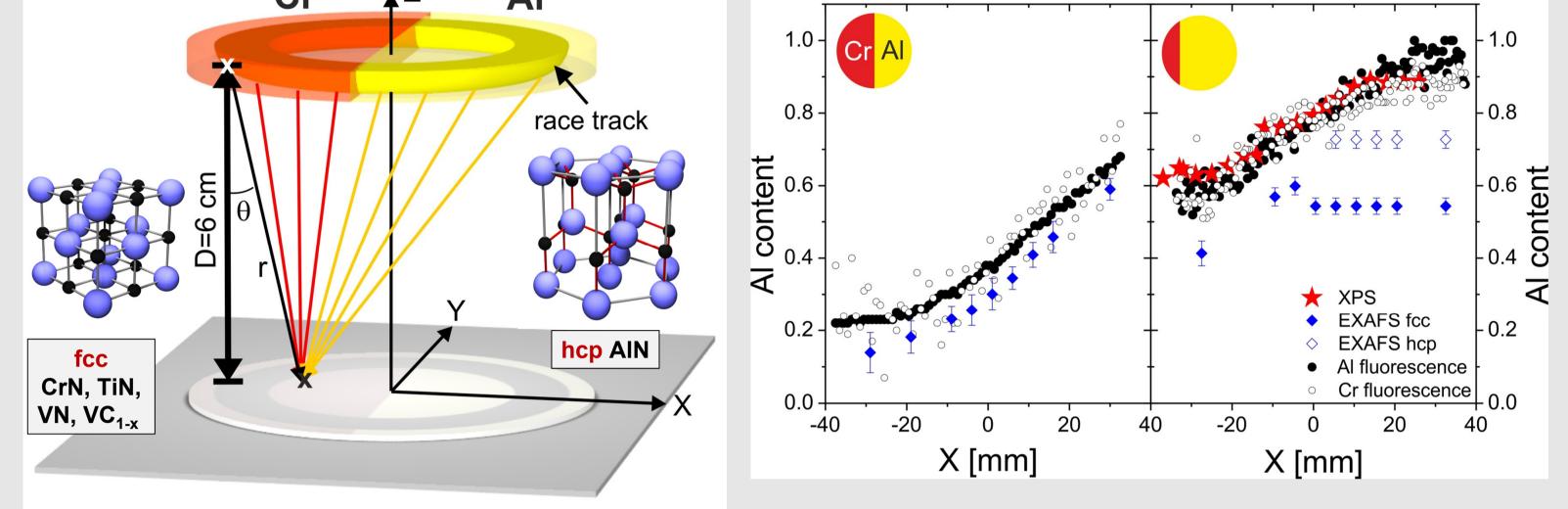
Introduction

Ternary hard coating materials such as CrAIN and TiAIN are widely used in industry. The hardness of the coatings is directly influenced by coexisting crystalline phases, crystallite size, and texture [1-5]. These are mainly controlled by the AI content and the growth conditions. Here we report a systematic XRD and EXAFS study of Cr-AI-N gradient thin films deposited by reactive magnetron sputtering from a segmented target. The influence of the sputter geometry and the chemical composition on the microstructure will be analyzed.

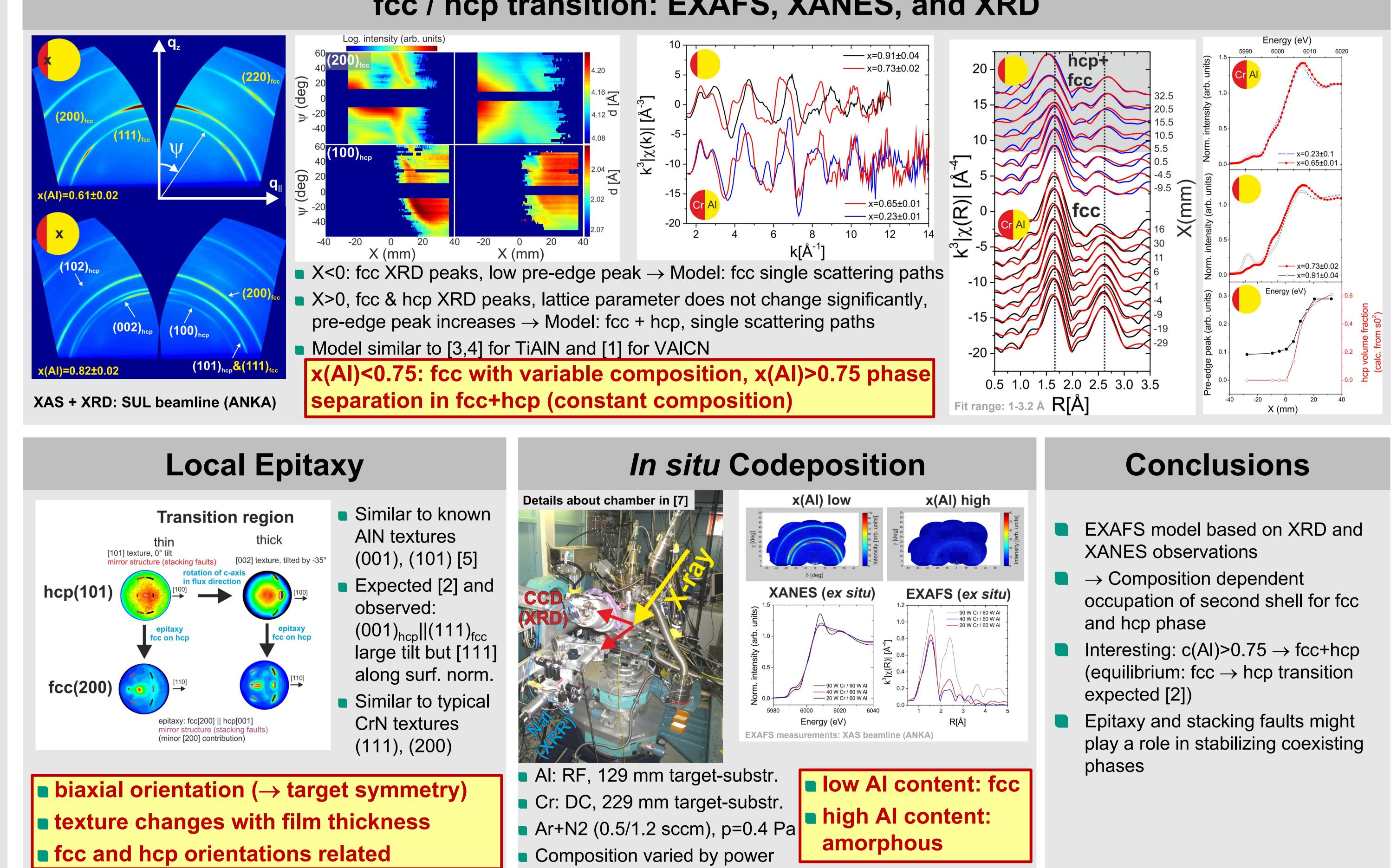


Cr-Al-N Gradient Samples

Cr **▲**∠ Al



- Reactive RF magnetron sputtering
- Sputter gas N2, 72 sccm, pressure 0.6 Pa
- 2 segmented targets with different Cr:Al ratio
- Large composition range, verified by fluorescence analysis and XPS
- fcc/hcp transition expected at c=0.75 [2]



fcc / hcp transition: EXAFS, XANES, and XRD

References

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